IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	09/810,387
Confirmation No	8779
Filing Date	March 15, 2001
Inventor	Craig M. Carpenter
Assignee	Micron Technology, Inc.
Group Art Unit	1792
Examiner	R. Zervigon
Attorney's Docket No	Ml22-1559
Customer No	021567
Title: Chemical Vapor Deposition Appa	aratuses and Deposition Methods

REQUEST FOR CONTINUED EXAMINATION FOLLOWING AUGUST 12, 2008 SUPPLEMENTAL EXAMINER'S ANSWER

To: MS RCE

Commissioner for Patents PO Box 1450

Art Unit 1763

Alexandria, VA 22313

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)

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AMENDMENTS